

Notice of References Cited	Application/Control No. 10/518,194		Applicant(s)/Patent Under Reexamination NOMURA ET AL.	
	Examiner EDNA WONG		Art Unit 1795	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*	O	JP 63250492 A	10-1988	Japan	SHIOBARA, TAKASHI	C25D 7/06
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
*	U	Masui et al., "Warp Control in Strip Processing Plant", ISIJ International, Vol. 31 (no month, 1991), No. 3, pp. 262-267.			
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	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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